684.2745

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

NAOTO SANO, ET AL.

Examiner: L. Scott, Jr

Group Art Unit: 2874

Application No.: 09/163,402

Filed: September 30, 1998

For: GAS LASER DEVICE AND

EXPOSURE APPARATUS USING :

THE SAME

February 29, 2000

1

The Assistant Commissioner for Patents Washington, D.C. 20231

PETITION UNDER 37 CFR 1.136(a)

Sir:

Applicants petition the Assistant Commissioner for Patents to extend the time for response to the Office Action dated August 30, 1999 for three months from November 30, 1999 to February 29, 2000.

Submitted herewith is a check for \$870.00 to cover the fee for the extension under 37 CFR 1.17. Any deficiency in or overpayment of this fee should be charged or credited

870.00 05

03/03/2000 WRN11 00000083 09163402

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to Deposit Account No. 06-1205. A duplicate of this petition is enclosed.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010.

All correspondence should be directed to our address listed below.

Respectfully submitted,

Attorney for Applicants Registration No. 33,326

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SEW:rle